

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takaaki NODA et al.

Application No.: New U.S. National Phase of  
PCT/JP2005/005699

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND APPARATUS  
FOR PROCESSING SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

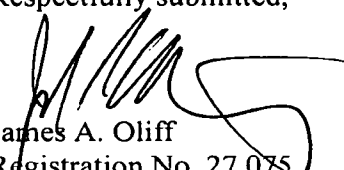
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See Reference 1.
- ☒ 3. One or more reference cited herein was cited in the International Search Report. A copy of the International Search Report is attached for the Examiner's information. See References 1 - 4.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. An English language Abstract of one or more non-English language reference is attached hereto. See References 1 - 4.

AP20 Rec'd PCT/PTO 27 JUL 2006

- ☒ 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1 - 4.
- ☒ 7. Reference 1 corresponds to reference 3. Reference 2 corresponds to reference 6.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

Joel S. Armstrong  
Registration No. 36,430

JAO:JSA/jtp

Date: July 27, 2006

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--

AP20 Rec'd PCT/JP 27 JUL 2006

Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128807		10/53/500		APPLICATION NO. New U.S. National Phase of PCT/JP2005/005699	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Takaaki NODA et al.					
				FILING DATE July 27, 2006					
U.S. PATENT DOCUMENTS									
Examiner Initials	Cite No.	Document Number	Date	Name					
	1	2003/0077920 A1	4/24/2003	NODA et al.					
	2	6,171,104 B1	1/9/2001	SAITO et al.					
FOREIGN PATENT DOCUMENTS									
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation			
	3	JP A 2003-178992	6/27/2003	Japan	X	X			
	4	JP A 2004-281832	10/7/2004	Japan	X	X			
	5	JP A 2001-234345	8/31/2001	Japan	X	X			
	6	JP A 2000-058543	2/25/2000	Japan	X	X			
OTHER DOCUMENTS									
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER				/Kelly Stouffer/			DATE CONSIDERED		
							02/06/2008		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									

Date: July 27, 2006

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KMS/